

Day : Friday
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Inventor Name Search Result

Your Search was:

for SNO9/617,254

Last Name = SHINRIKI

First Name = HIROSHI

10 En. fresh claims

Application#	Patent#	Status	Date Filed	Title	Inventor Name 49
<u>60510059</u>	Not Issued	159	10/09/2003	APPARATUS AND METHOD FOR FORMING A THIN FILM USING HIGH-SPEED VALVE CONTROL	SHINRIKI, HIROSHI
<u>10960600</u>	Not Issued	019	10/07/2004	APPARATUS AND METHOD FOR FORMING THIN FILM USING <u>UPSTREAM</u> AND <u>DOWNSTREAM</u> EXHAUST MECHANISMS	SHINRIKI, HIROSHI
<u>10946511</u>	Not Issued	018	09/20/2004 <i>ND</i>	SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD, HIGH SPEED ROTARY VALVE, AND CLEANING METHOD	SHINRIKI, HIROSHI
<u>10913531</u>	Not Issued	030	08/09/2004 <i>ND</i>	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SHINRIKI, HIROSHI
<u>10824798</u>	Not Issued	030	04/15/2004 <i>ND</i>	THIN-FILM DEPOSITION APPARATUS	SHINRIKI, HIROSHI
<u>10678045</u>	Not Issued	030	10/03/2003 <i>ND</i>	METHOD OF AND APPARATUS FOR PROCESSING SUBSTRATES	SHINRIKI, HIROSHI
<u>10473205</u>	Not Issued	030	04/09/2004 <i>ND</i>	METHOD AND DEVICE FOR PROCESSING SUBSTRATE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
<u>10457450</u>	Not Issued	071	06/10/2003 <i>ND</i>	FABRICATION PROCESS OF A SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
<u>10380696</u>	Not Issued	030	10/14/2003 <i>ND</i>	METHOD FOR FILM FORMATION OF GATE	SHINRIKI, HIROSHI

				INSULATOR, APPARATUS FOR FILM FORMATION OF GATE INSULATOR, AND CLUSTER TOOL	
<u>10344281</u>	<u>6806211</u>	150	08/25/2003 <i>W</i>	DEVICE AND METHOD FOR PROCESSING SUBSTRATE	SHINRIKI, HIROSHI
<u>10333406</u>	Not Issued	041	06/13/2003 <i>W</i>	METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, SUBSTRATE TREATER, AND SUBSTRATE TREATMENT SYSTEM	SHINRIKI, HIROSHI
<u>10311880</u>	Not Issued	030	03/12/2003 <i>W</i>	METHOD FOR FORMING THIN FILM AND APPATUS FOR FORMING THIN FILM	SHINRIKI, HIROSHI
<u>10310949</u>	Not Issued	071	12/06/2002 <i>W</i>	RADICAL PROCESSING OF A SUB-NANOMETER INSULATION FILM	SHINRIKI, HIROSHI
<u>10239648</u>	Not Issued	092	12/06/2002 <i>W</i>	METHOD OF FORMING A DIELECTRIC FILM	SHINRIKI, HIROSHI
<u>10133902</u>	Not Issued	061	04/29/2002 <i>W</i>	THIN FILM FORMING APPARATUS	SHINRIKI, HIROSHI
<u>09830121</u>	<u>6800139</u>	150	07/16/2001 <i>W</i>	FILM DEPOSITION APPARATUS AND METHOD	SHINRIKI, HIROSHI
09795437	Not Issued	161 <i>260</i>	03/01/2001	SINGLE-SUBSTRATE-HEAT- PROCESSING APPARATUS AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SHINRIKI, HIROSHI
<u>09658507</u>	<u>6485564</u>	150	11/13/2000	THIN FILM FORMING METHOD	SHINRIKI, HIROSHI
<u>09657627</u>	Not Issued	093	09/08/2000	METHOD OF FORMING A THIN FILM	SHINRIKI, HIROSHI
<u>09641681</u>	<u>6756235</u>	150	08/18/2000	METAL OXIDE FILM FORMATION METHOD AND APPARATUS	SHINRIKI, HIROSHI
<u>09631978</u>	<u>6467491</u>	150	08/03/2000	PROCESSING APPARATUS AND PROCESSING METHOD	SHINRIKI, HIROSHI
<u>09617254</u>	Not Issued	071	07/14/2000	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SHINRIKI, HIROSHI
<u>09613694</u>	<u>6428850</u>	150	07/10/2000	SINGLE-SUBSTRATE- PROCESSING CVD METHOD OF FORMING FILM	SHINRIKI, HIROSHI

				CONTAINING METAL ELEMENT	
<u>09598247</u>	<u>6482266</u>	150	06/21/2000 Nu	METAL ORGANIC CHEMICAL VAPOR DEPOSITION METHOD AND APPARATUS	SHINRIKI, HIROSHI
<u>09335526</u>	<u>6232248</u>	150	06/18/1999 W	SINGLE-SUBSTRATE-HEAT- PROCESSING APPARATUS AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SHINRIKI, HIROSHI
<u>09310132</u>	<u>6126753</u>	150	05/12/1999 W	SINGLE-SUBSTRATE- PROCESSING CVD APPARATUS AND METHOD	SHINRIKI, HIROSHI
<u>09134372</u>	<u>6001729</u>	150	08/14/1998 W	METHOD OF FORMING WIRING STRUCTURE FOR SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
<u>09081047</u>	<u>6063703</u>	150	05/19/1998 W	METHOD FOR MAKING METAL INTERCONNECTION	SHINRIKI, HIROSHI
<u>08889590</u>	<u>6143081</u>	150	07/08/1997	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SHINRIKI, HIROSHI
<u>08791161</u>	<u>5973402</u>	150	01/30/1997 W	METAL INTERCONNECTION AND METHOD FOR MAKING	SHINRIKI, HIROSHI
<u>08569319</u>	<u>5627102</u>	150	12/08/1995 W	METHOD FOR MAKING METAL INTERCONNECTON WITH CHLORINE PLASMA ETCH	SHINRIKI, HIROSHI
<u>08518322</u>	<u>5834846</u>	150	08/23/1995 X	SEMICONDUCTOR DEVICE WITH CONTACT STRUCTURE AND METHOD OF MANUFACTURING THE SAME	SHINRIKI, HIROSHI
<u>08353296</u>	<u>5565702</u>	250	12/05/1994 X	ANTIFUSE ELEMENT, SEMICONDUCTOR DEVICE HAVING ANTIFUSE ELEMENTS, AND METHOD FOR MANUFACTURING THE SAME	SHINRIKI, HIROSHI
<u>08353294</u>	<u>5641985</u>	150	12/05/1994 X	ANTIFUSE ELEMENT AND SEMICONDUCTOR DEVICE HAVING ANTIFUSE ELEMENTS	SHINRIKI, HIROSHI
<u>08353287</u>	<u>5679974</u>	150	12/05/1994 X	ANTIFUSE ELEMENT AND SEMICONDUCTOR DEVICE HAVING ANTIFUSE	SHINRIKI, HIROSHI

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				ELEMENTS	
08274427	Not Issued	161	07/13/1994	METHOD AND APPARATUS FOR FORMING A THIN FILM ON A SEMICONDUCTOR SUBSTRATE	SHINRIKI , HIROSHI
08264928	5652180	150	06/24/1994	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE WITH CONTACT STRUCTURE	SHINRIKI , HIROSHI
08228257	5521423	150	04/15/1994	DIELECTRIC STRUCTURE FOR ANTI-FUSE PROGRAMMING ELEMENT	SHINRIKI , HIROSHI
08215581	Not Issued	166	03/22/1994	METAL INTERCONNECTION AND METHOD FOR MAKING	SHINRIKI , HIROSHI
07883531	5292673	150	05/15/1992	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	SHINRIKI , HIROSHI
07846828	5336638	150	03/06/1992	PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICES	SHINRIKI , HIROSHI
07812836	Not Issued	161	12/20/1991	CAPACITOR AND PRODUCTION METHOD	SHINRIKI , HIROSHI
07561602	Not Issued	161	08/02/1990	METHOD OF MAUFACTURING A SEMICONDUCTOR DEVICE	SHINRIKI , HIROSHI
07517323	5079191	150	05/01/1990	PROCESS FOR PRODUCING A SEMICONDUCTOR DEVICE	SHINRIKI , HIROSHI
07469377	Not Issued	166	01/24/1990	CAPACITOR AND PRODUCTION METHOD	SHINRIKI , HIROSHI
07247343	4937650	150	09/21/1988	SEMICONDUCTOR CAPACITOR DEVICE WITH DUAL DIELECTRIC	SHINRIKI , HIROSHI
07081231	4891684	150	08/04/1987	SEMICONDUCTOR DEVICE	SHINRIKI , HIROSHI
06936603	Not Issued	161	12/01/1986	SEMICONDUCTOR DEVICE AND PROCESS FOR PRODUCING THE SAME	SHINRIKI , HIROSHI
06860413	4809052	150	05/07/1986	SEMICONDUCTOR MEMORY DEVICE	SHINRIKI , HIROSHI

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Last Name = SHINRIKI

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Inventor Name Search Result

Your Search was:

Last Name = SUGIRA

First Name = MASHITO

← spelled different on parent

the case

Application#	Patent#	Status	Date Filed	Title	Inventor Name 1
<u>09617254</u>	Not Issued	071	07/14/2000	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SUGIRA, MASHITO

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Inventor Name Search Result

Your Search was:

Last Name = SUGIURA

First Name = MASAHIITO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 15
<u>10927102</u>	Not Issued	030	08/27/2004 X	FILM FORMING METHOD AND FILM FORMING APPARATUS	SUGIURA, MASAHIITO
<u>10913531</u>	Not Issued	030	08/09/2004 X	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SUGIURA, MASAHIITO
<u>10673908</u>	Not Issued	041	09/30/2003 X	LOW-PRESSURE DEPOSITION OF METAL LAYERS FROM METAL-CARBONYL PRECURSORS	SUGIURA, MASAHIITO
<u>10673648</u>	Not Issued	071	09/30/2003 X	METHOD OF DEPOSITING METAL LAYERS FROM METAL-CARBONYL PRECURSORS	SUGIURA, MASAHIITO
<u>10487989</u>	Not Issued	020	02/27/2004 X	METHOD AND APPARATUS FOR FORMING FILM	SUGIURA, MASAHIITO
<u>10312292</u>	Not Issued	041	09/29/2003 X	ETCHING METHOD	SUGIURA, MASAHIITO
<u>10258475</u>	Not Issued	041	04/21/2003 X	SEMICONDUCTOR DEVICE HAVING A LOW DIELECTRIC FILM AND FABRICATION PROCESS THEREOF	SUGIURA, MASAHIITO
<u>10095025</u>	6800546	150	03/12/2002 X	FILM FORMING METHOD BY RADIATING A PLASMA ON A SURFACE OF A LOW DIELECTRIC CONSTANT FILM	SUGIURA, MASAHIITO
<u>10069274</u>	Not Issued	093	06/11/2002 X	FABRICATION PROCESS OF A SEMICONDUCTOR DEVICE	SUGIURA, MASAHIITO
<u>09795437</u> X	Not Issued	161	03/01/2001	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS	SUGIURA, MASAHIITO

				AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	
<u>09631978</u>	<u>6467491</u>	150	08/03/2000 ✓	PROCESSING APPARATUS AND PROCESSING METHOD	SUGIURA, MASAHITO
<u>09613694</u>	<u>6428850</u>	150	07/10/2000 ✗	SINGLE-SUBSTRATE- PROCESSING CVD METHOD OF FORMING FILM CONTAINING METAL ELEMENT	SUGIURA, MASAHITO
<u>09335526</u>	<u>6232248</u>	150	06/18/1999 ✓	SINGLE-SUBSTRATE-HEAT- PROCESSING APPARATUS AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SUGIURA , MASAHITO
<u>08889590</u> —	<u>6143081</u>	150	07/08/1997	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SUGIURA , MASAHITO
<u>08687951</u>	<u>5755963</u>	150	07/26/1996 ✓	FILTER ELEMENT AND FABRICATION METHOD FOR THE SAME	SUGIURA , MASAHITO

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